

F rm 1449 (Modifi d)

Informati n Disclosure Stat m nt By Applicant

(Use Several Sheets if Necessary)

Attorney Docket No:

LAM1P106.A

Applicant:

Jay E. Uglow et al.

Filing Date:

February 16, 2001

U.S. Serial No:

Unassigned

Group:

Unassigned 21/3

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Foreign Patent or Published Foreign Patent Application

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Examiner	(Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Form 1449 (Modified)

Information Disclosure Statement By Applicant

(Use Several Sheets if Necessary)

Attorney Docket No:

LAMIPI06.A

U.S. Serial No: 09/785,999

Applicant:

Jay E. Uglow et al.

Filing Date: February 16, 2001 Group: 2813____

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Examiner Initial	No.	Patent No.	Date	Patentee	Class	class_	Date
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Foreign Patent or Published Foreign Patent Application

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Form 1449 (Modified)

Informati n Disclosure Statement By Applicant

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Attorney Docket No:

LAM1P106.A

U.S. Serial No: 09/785,999

Applicant:

Jay E. Uglow et al.

Filing Date:

Group:

February 16, 2001 2813

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	Examiner						Sub-	Filing
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Foreign Patent or Published Foreign Patent Application

Examiner		Document	Publication	Country or		Sub-	Trans	ation
Initial	No.	No. c	Date	Patént Office	Class	class	Yes	No
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	М							
	N							
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Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
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Examiner		Date Considered 12/23/02

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Complete if Known					
Application Number 09/785,999					
Filing Date	February 16, 2001				
First Named Inventor	Jay Uglow				
Art Unit	2813				
Examiner Name	Kielin, Erik J.				
Attorney Docket Number	LAM1P106A				

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Sheet 1 of 1 Att

U.S. Patent Documents

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Examiner Cite		Document Number	Issue or Publication	Name of Patentee or Applicant of Cited	Pages, Columns, Lines, where Relevant						
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Non Patent Literature Documents

Examiner Initial	Cite No.	Include name of author (in CAPTIAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published						
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¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶Applicant is to place a check mark here if English language translation is attached.